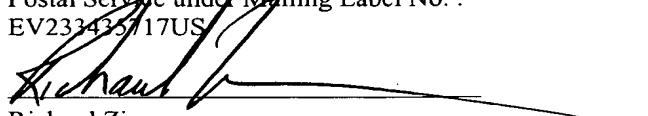


PATENT  
30205/37328A

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application of: Min Ho Jung et al. ) I hereby certify that this Continuing  
Serial No.: To be assigned ) Application Transmittal and the  
Filed: February 27, 2004 (Herewith) ) documents referred to as enclosed  
For: Additive for Photoresist ) therewith are being deposited with the  
Composition for Resist Flow Process ) United States Postal Service on  
Group Art Unit: To be assigned ) February 27, 2004, in an envelope  
Examiner: To be assigned ) addressed to the Commissioner for  
Patents, P.O. Box 1450  
Alexandria, Virginia 22313-1450,  
utilizing the "Express Mail Post Office to  
Addressee" service of the United States  
Postal Service under Mailing Label No. .  
EV233435117US  
  
Richard Zimmermann

**PRELIMINARY AMENDMENT**

Mail Stop Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

Please enter the following preliminary amendment in the above-referenced  
divisional application.